



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Patent Application of:

Woon-Yong PARK, *et. al.*

Serial No.: 10/627,752

Confirmation No.: 4396

Filed: July 28, 2003

Docket No.: 6192.0091.D2

Group Art Unit: 1756

Examiner: Nicole M. BARRECA

For: **PHOTOLITHOGRAPHY METHOD FOR THIN FILM**

Mail Stop - Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria , VA 22313-1450

REPLY AND AMENDMENT UNDER 37 C.F.R. § 1.111

Sir:

In response to the Non-Final Office Action mailed November 30, 2004 (Paper No. 20041126) ("Office Action"), Applicants respectfully request reconsideration of the application in view of the following Amendments and Remarks.

Attached is a Petition for a One-Month Extension of Time. If further extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned for under 37 C.F.R. §1.136(a). Applicants believe that no further fees for net addition of claims are required at this time. Any fees required for further extensions of time and any fees for the net addition of claims are hereby authorized to be charged to our Deposit Account No. 23-1951.